

Practitioner's Docket No. MI22-1098

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Schuegraf, Klaus F.

Application No.: 09/212,726

Group No.: 2813

Filed: 12/15/1998

Examiner: Erik Kielin

For: Semiconductor Processing Methods of Chemical Vapor Depositing SiO₂ on a Substrate

Assistant Commissioner for Patents

Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.
2. There is an error with respect to the following, which is incorrectly entered.

CERTIFICATE OF MAILING/TRANSMISSION (37 C.F.R. section 1.8a)

I hereby certify that this correspondence is, on the date shown below, being:

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- ☐ deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

FACSIMILE

- ☒ transmitted by facsimile to the Patent and Trademark Office to 703-308-7751
6 pages

Date: 3/7/2002

Jaime M. White
Signature

Jaime M. White fax no. 509-838-3424
(type or print name of person certifying)

(Request for Corrected Filing Receipt--page 1 of 2)

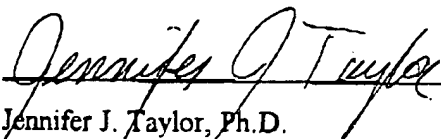
*Error in**Correct data*

1. CPA filed on: 11/30/2001

1. CPA filed on: 01/30/2001

3. The correction is not due to any error by applicant and no fee is due.

Date: 3-7-2002



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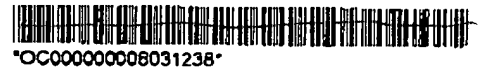
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/212,726	12/15/1998	2813	838	M122-1098	2	10	4

21567
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CONFIRMATION NO. 7984**CORRECTED FILING RECEIPT**

OC000000006031238

Date Mailed: 05/02/2001

Receipt is acknowledged of a CPA in this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

KLAUS F. SCHUEGRAF, BOISE, ID;

Domestic Priority data as claimed by applicant**Foreign Applications**

If Required, Foreign Filing License Granted 01/29/1999

CPA filed on: 11/30/2001

Projected Publication Date: 08/09/2001

Non-Publication Request: No

Early Publication Request: No

Title

SEMICONDUCTOR PROCESSING METHODS OF CHEMICAL VAPOR DEPOSITING SiO₂
ON A SUBSTRATE

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3/12/02
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

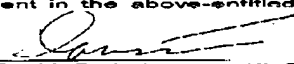
Application Serial No. 09/212,726
Filing Date December 15, 1999
Inventor Klaus F. Schuegraf
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Erik Klein
Attorney's Docket No. M122-1090
Title: Semiconductor Processing Methods of Chemical Vapor Depositing SiO₂ on a
Substrate

Assistant Commissioner of Patents
Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY

Please recognize Jennifer J. Taylor, Ph.D. (Reg. No. 48,711) whose
post office address is 601 W. First Avenue, Suite 1300, Spokane, Washington
99201-3828, as an associate attorney or agent in the above-entitled application.

Date: 3/7/02


David B. Latwesen, Ph.D.
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